

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

Atsushi MIYAMOTO, et al.

Application No.:

Filed:

For: METHOD OF CLASSIFYING  
DEFECTS

Examiner:

Art Unit:

INFORMATION DISCLOSURE  
STATEMENT UNDER 37 CFR §1.97 and  
§1.98

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

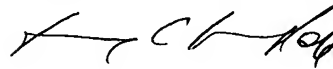
Sir:

The references cited on attached form PTO/SB/08A and PTO/SB/08B are being called to the attention of the Examiner. Copies of the references are enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Applicant believes that no fee is required for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'Chun-Pok Leung', written in a cursive style.

Chun-Pok Leung  
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60121687 v1

Substitute for form 1449A/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(use as many sheets as necessary)</i>			<b>Complete if Known</b>		
			Application Number		
			Filing Date		
			First Named Inventor	MYAMOTO, Atsushi	
			Art Unit		
Examiner Name					
Sheet	1	of		Attorney Docket Number	16869N-103800US

U.S. PATENT DOCUMENTS+					
		Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
Examiner Initials*	Cite No. <sup>1</sup>	Number Kind Code <sup>2</sup> ( <i>if known</i> )			
	AA	US-6,148,099	11-14-2000	Neopath, Inc	(related to BB and BC)
	AB	US-2001/0048761 A1	12-06-2001	Hamamatsu et al.	(related to BE)
	AC	US-			
	AD	US-			
	AE	US-			
	AF	US-			
	AG	US-			
	AH	US-			
	AI	US-			
	AJ	US-			
	AK	US-			
	AL	US-			
	AM	US-			
	AN	US-			
	AO	US-			
	AP	US-			
	AQ	US-			
	AR	US-			
	AS	US-			
	AT	US-			

FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)				
	AU	JP	2001-135692		05-18-2001	Applied Materials		<input checked="" type="checkbox"/>
	AV	JP	1999-344450		12-14-1999	Hitachi		<input checked="" type="checkbox"/>
	AW	JP	2001-127129		05-11-2001	Hitachi		<input checked="" type="checkbox"/>
	AX	JP	2001-134763		05-18-2001	Hitachi		<input checked="" type="checkbox"/>
	AY	JP	2001-256480		09-21-2001	Hitachi		<input checked="" type="checkbox"/>
	AZ	JP	2001-331748		11-30-2001	Ichikawa Akira		<input checked="" type="checkbox"/>
	BA	JP	2002-090312		03-27-2002	Hitachi		<input checked="" type="checkbox"/>
	BB	JP	2001-509619		07-24-2001	Neopath, Inc	related to BC	<input type="checkbox"/>
	BC	WO	99/01842 A1		01-14-1999	Neopath, Inc	related to BB	
	BD	JP	2000-57349A		02-25-2000	Hitachi		X
	BE	JP	2001-250852A		09-14-2001	Akira Hamamatsu	related to AB	
	BF	JP	2000-097871		04-07-2000	Hitachi		X

Examiner Signature		Date Considered	
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\* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. <sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> Kind Codes of U.S. Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.